



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventors: Douglas J. Tweet, et al.

Serial No.: 10/807,931

Filed: March 23, 2004

Title: METHOD TO FORM LOCAL
SILICON-ON-NOTHING OR
SILICON-ON-INSULATOR
WAFERS WITH TENSIL-
STRAINED SILICON

PATENT APPLICATION

Attorney Docket No.
SLA0586

Group No. 2812

Examiner: W. L. Lindsay, Jr.

Confirmation No. 5155

Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

**ASSOCIATE POWER OF ATTORNEY
CHANGE OF CORRESPONDENCE ADDRESS**

I hereby appoint Robert D. Varitz of 4915 S.E. 33rd Place, Portland, Oregon 97202, U. S. Patent and Trademark Office Registration Number 31436, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please change the Correspondence Address to that associated with Customer Number 55,376.

Date: 9/20/05

Respectfully submitted, ~


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